BACHELOR'S PROGRAMME 2nd YEAR OF STUDY, 2nd SEMESTER

Course title	VACUUM PHYSICS AND TECHNOLOGY	
COURSECODE		
COURSE TYPE	full attendance	
COURSE LEVEL	1 st cycle (bachelor's degree)	
YEAR OF STUDY, SEMESTER	2 nd year of study, 2 nd semester	
	3	
NUMBER OF ECTS CREDITS		
NUMBER OF HOURS PER WEEK	4 (2 lecture hours + 2 laboratory hours)	
NAME OF LECTURE HOLDER	Prof. univ. dr. habil. Lucel SIRGHI	
NAME OF SEMINAR HOLDER	Prof. univ. dr. habil. Lucel SIRGHI	
Prerequisites	Advanced level of English	
A GENERAL AND COURSE-SPECIF	IC COMPETENCES	
General competences:		
	ement and extension of the use of physical models and their validation using	
	pable of validating a physical model.	
	echniques in a multidisciplinary team on various hierarchical levels.	
	for continuous training and efficient use of resources and learning techniques for	
their own development.		
Course-specific competences:	control of applied angine arian acian acia	
·	icepts of applied engineering sciences.	
theories and tools.	Explaining the structure and operation of the components of different types of equipment using specific theories and tools	
	cations in engineering practice in the field of specialization, using theoretical	
foundations of applied e		
	ing physical phenomena and operationalizing key concepts based on the	
appropriate use of labor		
	experiment results, including the degree of uncertainty of the experimental results	
obtained.		
B LEARNING OUTCOMES		
	his dissipling students will be able to:	
	 pon successful completion of this discipline, students will be able to: Explain physical phenomena specific to the vacuum technique. 	
	of vacuum pumps, instruments used for pressure measurements, mass flow	
 Describe the operation of vacuum pumps, instruments used for pressure measurements, mass now measurement instruments. Use pumps and vacuum measuring instruments. 		
LECTURE CONTENT		
Introductory concepts. Definition	ns. Vacuum characteristic quantities. Vacuum in nature, in laboratory installations	
and in industrial installations. Bri	ief history of vacuum science. Applications of vacuum in science, industry,	
measuring instruments and in ex	•	
	Elements of kinetic theory of gases. Laws of perfect gases. Flow of rarefied gases. Real gases. Thermal conductivity,	
viscosity and diffusion of rarefied	-	
	the vacuum-solid interface. Adsorption and desorption. Contamination rate of	
surfaces of solid bodies in vacuu		
	Methods of producing vacuum. Vacuum pumps: mechanical pumps, driving jet vacuum pumps and turbomolecular	
pumps.		
Condensation vacuum pumps an		
	Pressure sensors for coarse vacuum, medium, high and ultrahigh vacuum.	
-	um installations. Conductance of components used in vacuum installations	
-	stallations for research and industrial applications. Choice of pump types and	
	nstallations. Choice of construction solutions and dimensioning of vacuum	
systems.	a in research and industry. Dertiquierities of use of you was numer and instruments	
	s in research and industry. Particularities of use of vacuum pumps and instruments	
	-	
for measuring low pressures in va	n microscony. X ray photoglactron chaotromatry particle accelerators	
for measuring low pressures in va Vacuum systems used in electro	n microscopy, X-ray photoelectron spectrometry, particle accelerators	
for measuring low pressures in va Vacuum systems used in electron Mass spectrometry in vacuum te	chnology. Measurement of partial pressures and analysis of residual gases. Control	
for measuring low pressures in va Vacuum systems used in electron Mass spectrometry in vacuum ter of the tightness of vacuum install	chnology. Measurement of partial pressures and analysis of residual gases. Control lations.	
for measuring low pressures in va Vacuum systems used in electron Mass spectrometry in vacuum te of the tightness of vacuum install Vacuum systems used in thin lay	chnology. Measurement of partial pressures and analysis of residual gases. Control	
for measuring low pressures in va Vacuum systems used in electron Mass spectrometry in vacuum te of the tightness of vacuum install Vacuum systems used in thin lay vacuum installations.	chnology. Measurement of partial pressures and analysis of residual gases. Control lations. er deposition. Preventive and remedial measures in case of contamination of	
for measuring low pressures in vaVacuum systems used in electronMass spectrometry in vacuum terof the tightness of vacuum installVacuum systems used in thin layvacuum installations.DRECOMMENDED READING FOR	chnology. Measurement of partial pressures and analysis of residual gases. Control lations. er deposition. Preventive and remedial measures in case of contamination of	

		nm science, technology and applications, CRC Press Taylor & Francis Group, 2018 nology, Editia a-III-a, Elsevier, 1996.		
Е	LABORATORY CONTENT			
	Preliminary notions of vacuum	science. Pressure and laws of ideal gas. Physical quantities characteristic of vacuum		
	(seminar).			
	Calculation of particle density,	flux densities and contamination rate of solid surfaces in vacuum (seminar).		
Calculation of conductance of elements of vacuum installations (seminar).				
	Study of thermal conduction of rarefied gases (laboratory). Determination of pumping speed of a pump at constant volume and constant pressure.			
Study of Boyle-Mariotte law in vacuum (laboratory) Calibration of a needle valve for controlling mass flow rates of rarefied gases (laboratory).				
		r controlling mass flow rates of rarefied gases (laboratory).		
Study of thermal flow meter (laboratory). Study of thermal probe (laboratory)				
				Study of hot cathode ionization probe (laboratory) Electrical discharges in direct current in rarefied gases. Measurement of ignition voltage of hot cathode discharge
	(laboratory).			
	Methods of cleaning and tightness control of vacuum installations (laboratory). Mass spectrometry in vacuum technology. Measurement of partial pressures and analysis of residual gases (laboratory).			
_	Evaluation of practical laborato			
	RECOMMENDED READING FO	R LABORATORY/SEMINARS		
	1. G. Marin – Tehnica vidului si aplicatiile ei in industrie, Ed. Tehnica, Bucuresti, 1983			
 Igor Bello, Vacuum and Ultravacuum, CRC Press, Taylor and Francis Group, Boca Raton, FL 2018. G. Popa, D. Alexandroaei, Îndrumar de lucrări practice pentru fizica plasmei, Ed. Universității Alexandru Ioan Cuza, Iași, 1991 G. Popa, L. Sîrghi – Bazele fizicii plasmei, Ed. Universității Alexandru Ioan Cuza, Iași, 2000 N. Dumitrascu – Introducere in fizica plasmei, Iasi, Ed. Junimea, 1999 				
		6. O. B. Malyshev, Vacuum in Particle Accelerators, Willey-VCH Wenheim, Germany, 2020		
		3	EDUCATION STYLE	
		LEARNING AND TEACHING		Lecture, debate, discovery, problematizing, algorithm, debate,
		METHODS		individual project
ASSESSMENT METHODS		• Two written papers (week 7 and week 14)		
		Laboratory reports		
	AGE OF INSTRUCTION			
ANGU		• English		